



US00D947914S

(12) **United States Design Patent** (10) **Patent No.:** **US D947,914 S**
Rao et al. (45) **Date of Patent:** **** Apr. 5, 2022**

(54) **BASE PLATE FOR A PROCESSING CHAMBER SUBSTRATE SUPPORT**

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(**) Term: **15 Years**

(21) Appl. No.: **29/759,527**

(57) **CLAIM**

(22) Filed: **Nov. 23, 2020**

The ornamental design for a base plate for a processing chamber substrate support, as shown and described.

(51) **LOC (13) Cl.** **15-09**

(52) **U.S. Cl.**
USPC **D15/144.1; D13/182**

(58) **Field of Classification Search**
USPC D23/249, 259, 262, 269; D15/138, 139, D15/143, 144, 144.1, 144.2, 150, 199; D13/118, 122, 133, 162, 182, 184, 199; D22/113, 119
CPC H01J 37/3414; H01J 37/3423; H01L 21/02631; H01L 2221/68363; H01L 2224/75186-75189; H01L 21/67742; H01L 21/0226; H01L 21/02263; H01L 21/02266; H01L 21/02269; H01L
(Continued)

DESCRIPTION

FIG. 1 is a top isometric view of a base plate for a processing chamber substrate support, according to the novel design.
FIG. 2 is a bottom isometric view thereof.
FIG. 3 is a top plan view thereof.
FIG. 4 is a bottom plan view thereof.
FIG. 5 is a front elevation view thereof.
FIG. 6 is a back elevation view thereof.
FIG. 7 is a left side elevation view thereof.
FIG. 8 is a right side elevation view thereof.
FIG. 9 is a cross-sectional view taken along line 9-9 in FIG. 3; and,
FIG. 10 is a cross-sectional view taken along line 10-10 in FIG. 3.
The broken lines in the drawings depict portions of the article that form no part of the claimed design.

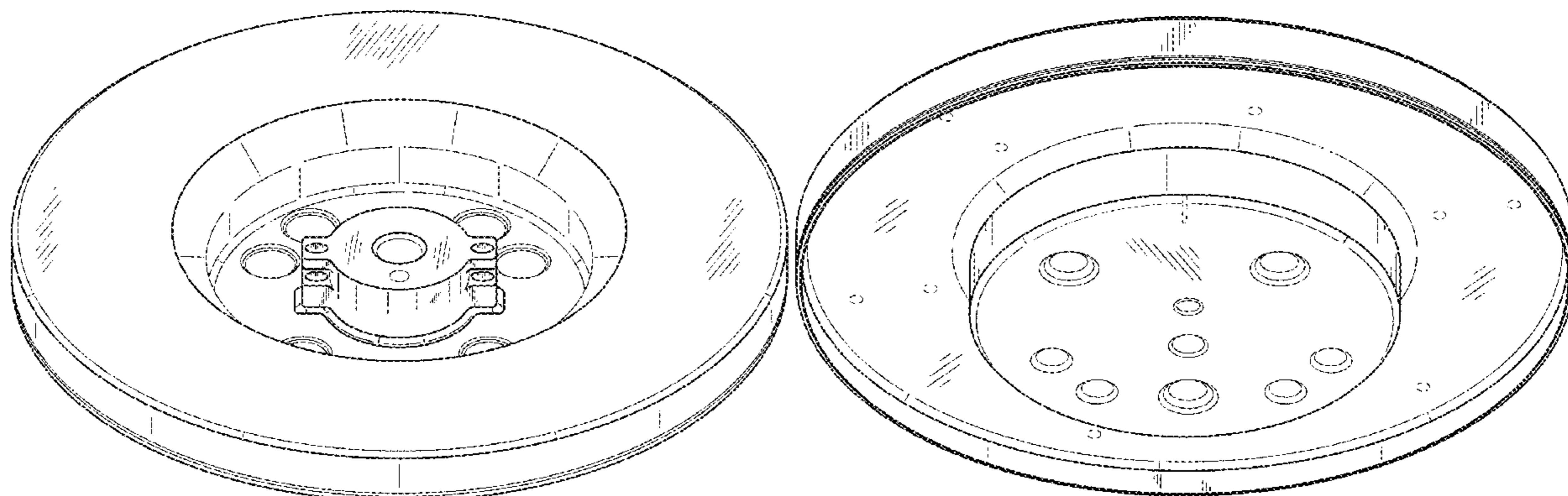
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1 Claim, 6 Drawing Sheets



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(58) **Field of Classification Search**

CPC 21/02271; F16J 7/00; E04D 13/14; C23C
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See application file for complete search history.

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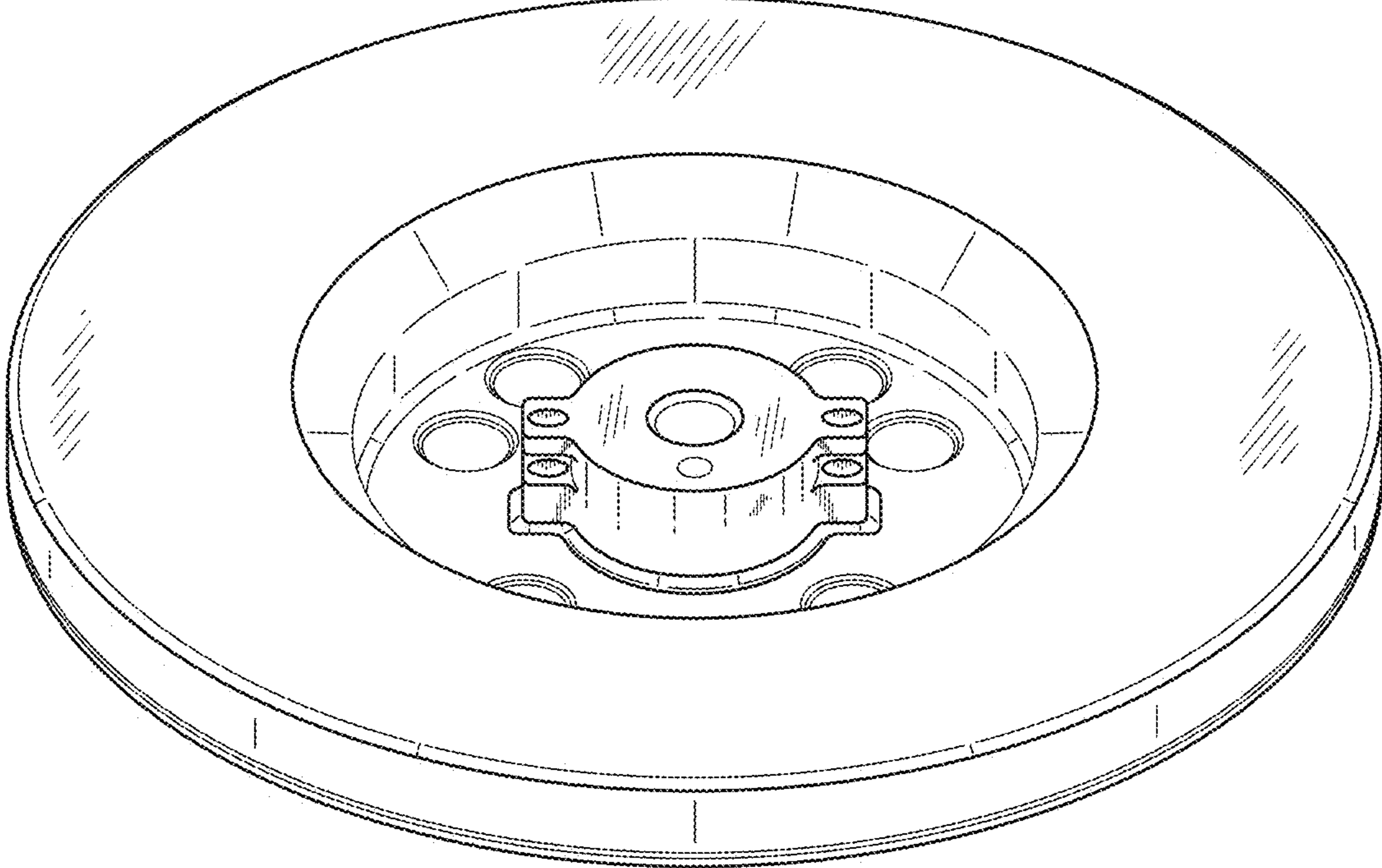


FIG. 1

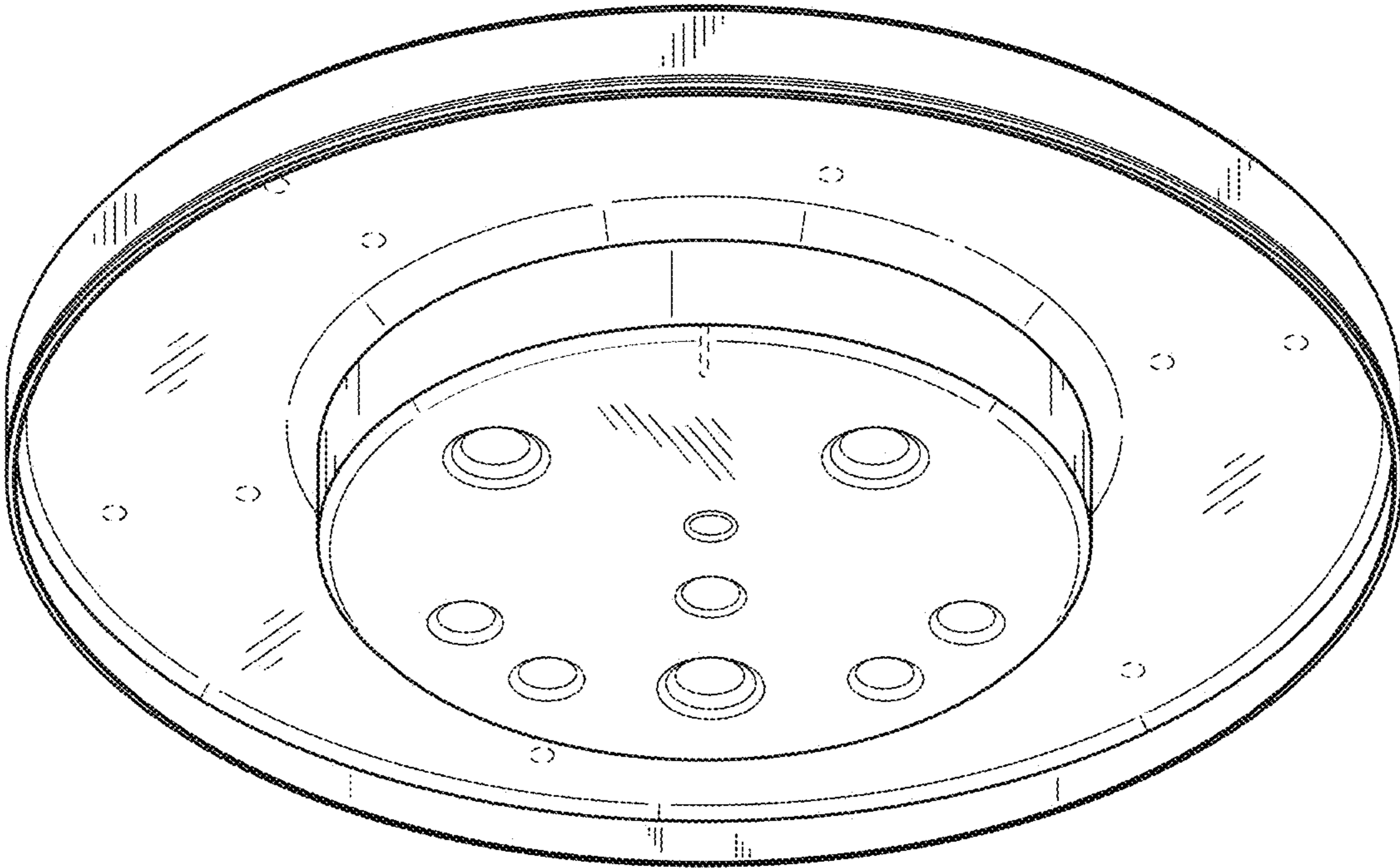


FIG. 2

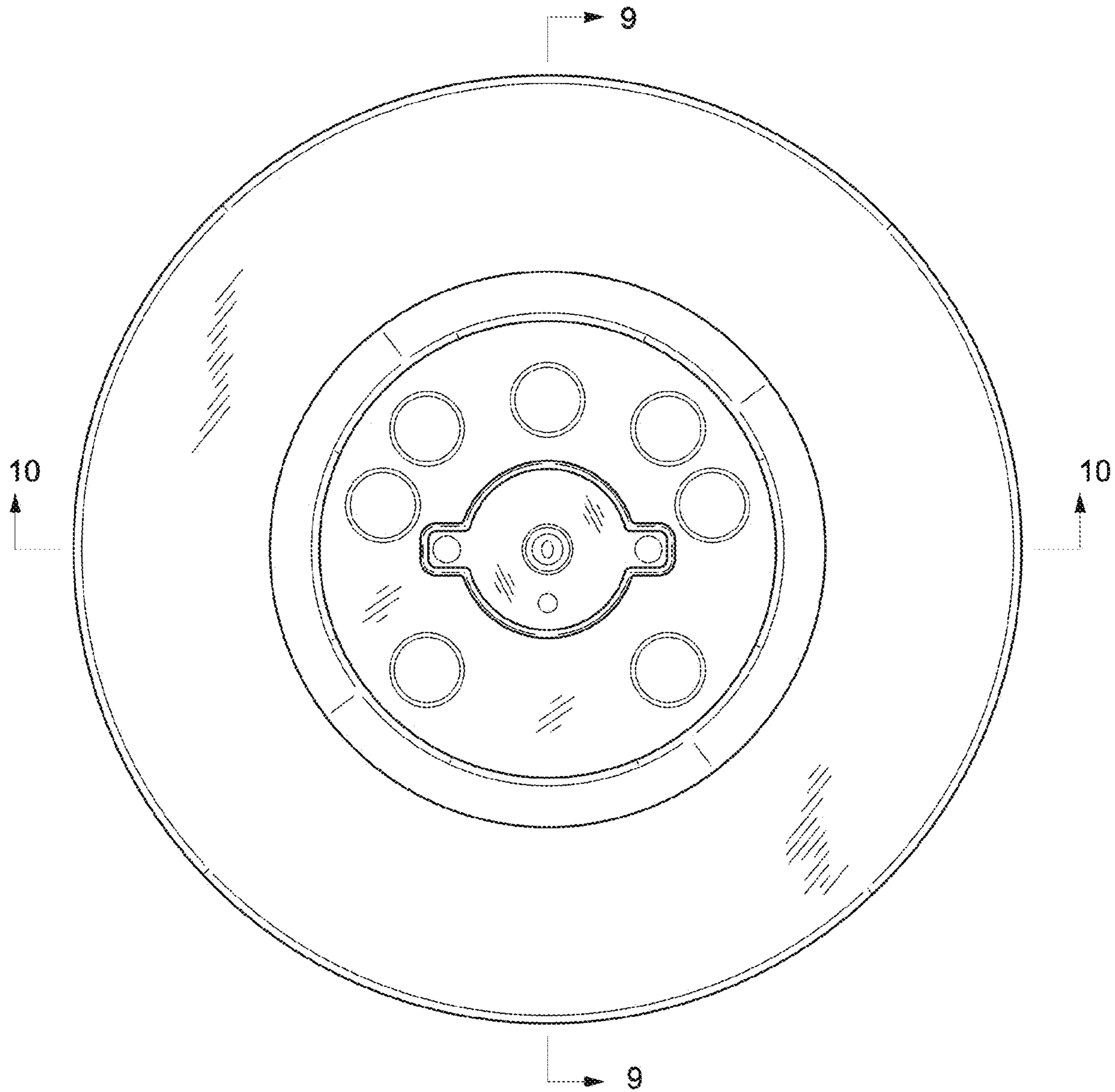


FIG. 3

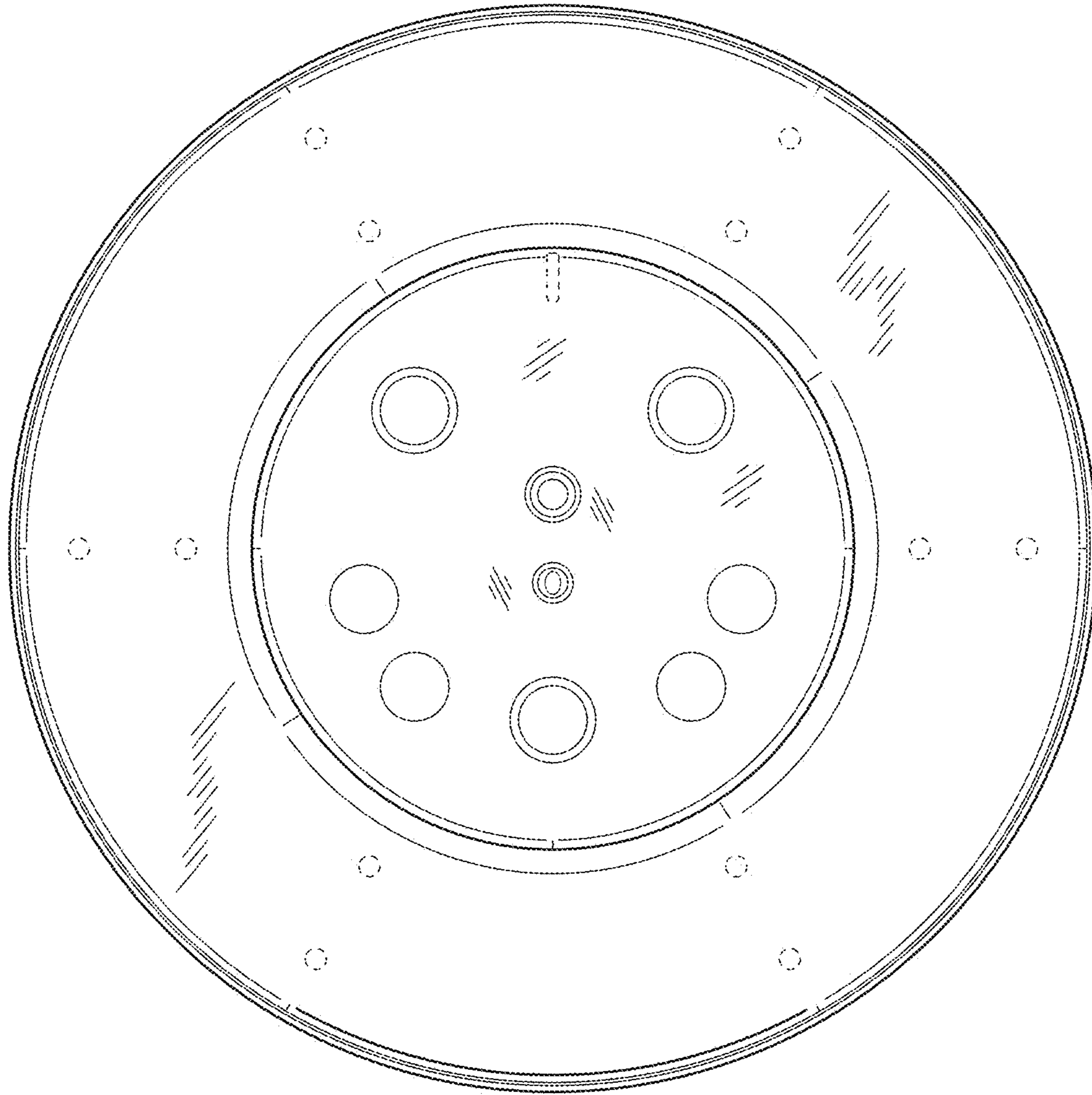


FIG. 4

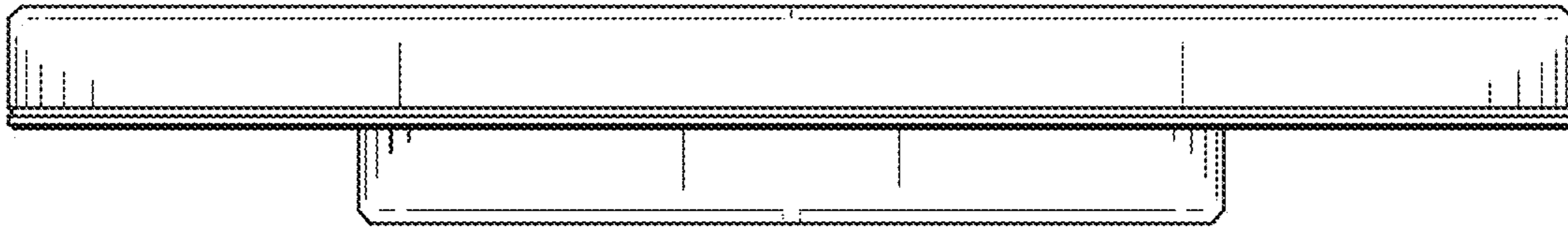


FIG. 5

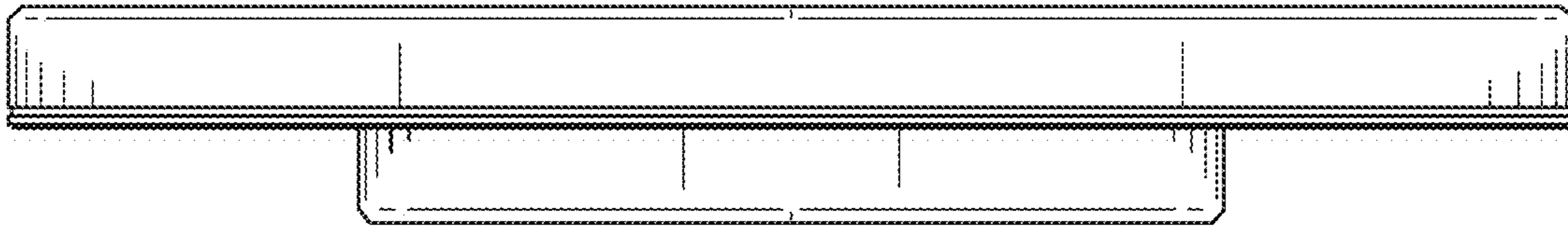


FIG. 6

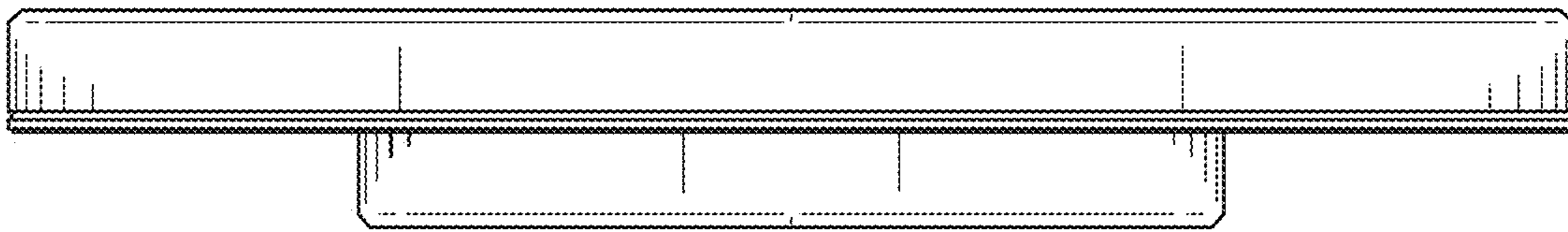


FIG. 7

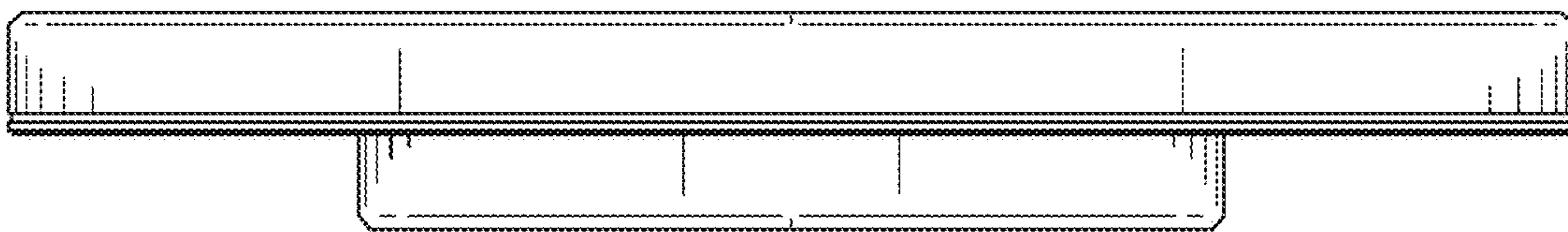


FIG. 8

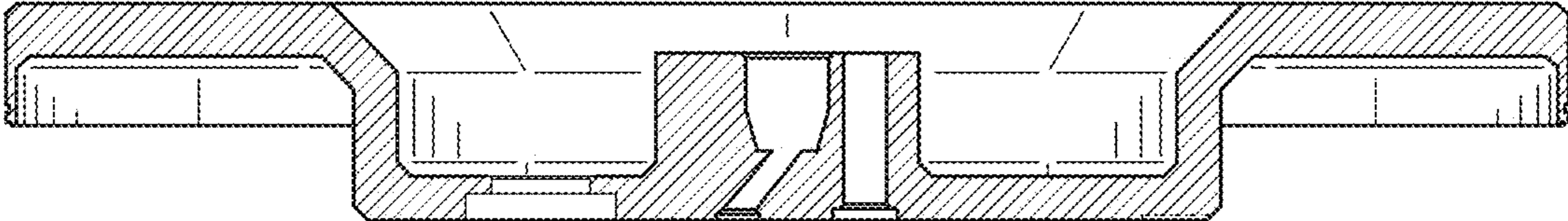


FIG. 9

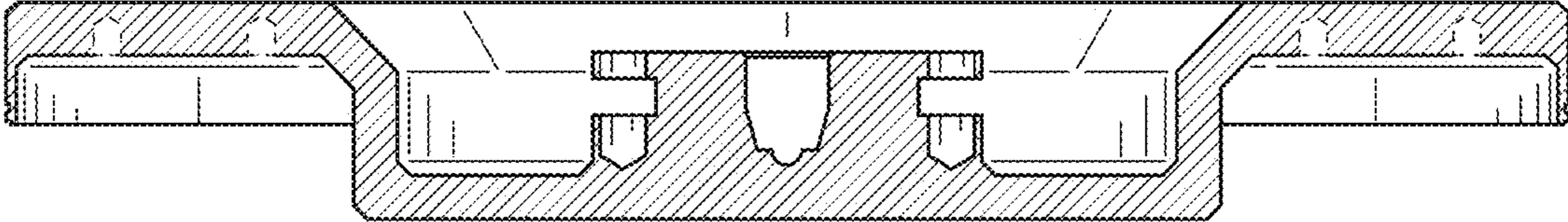


FIG. 10